

Notice of References Cited	Application/Control No. 09/741,857		Applicant(s)/Patent Under Reexamination MODELSKI ET AL.	
	Examiner Chad Zhong		Art Unit 2152	Page 1 of 1

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	B	US-6,625,150	09-2003	Yu, JungJi John	370/389
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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	"The RISC Concept - A survey of Implementations", Esponda et al., September 1991
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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